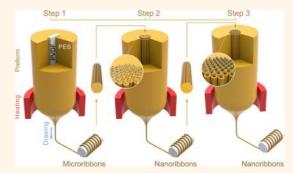
# Spontaneous High Piezoelectricity in Poly(vinylidene fluoride) Nanoribbons Produced by Iterative Thermal Size Reduction Technique

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ABSTRACT We produced kilometer-long, endlessly parallel, spontaneously piezoelectric and thermally stable poly(vinylidene fluoride) (PVDF) micro- and nanoribbons using iterative size reduction technique based on thermal fiber drawing. Because of high stress and temperature used in thermal drawing process, we obtained spontaneously polar  $\gamma$  phase PVDF micro- and nanoribbons without electrical poling process. On the basis of X-ray diffraction (XRD) analysis, we observed that PVDF micro- and nanoribbons are thermally stable and conserve the polar  $\gamma$  phase even after being exposed to heat treatment above the melting point of PVDF. Phase transition mechanism is investigated and explained using



ab initio calculations. We measured an average effective piezoelectric constant as -58.5 pm/V from a single PVDF nanoribbon using a piezo evaluation system along with an atomic force microscope. PVDF nanoribbons are promising structures for constructing devices such as highly efficient energy generators, large area pressure sensors, artificial muscle and skin, due to the unique geometry and extended lengths, high polar phase content, high thermal stability and high piezoelectric coefficient. We demonstrated two proof of principle devices for energy harvesting and sensing applications with a 60 V open circuit peak voltage and 10  $\mu$ A peak short-circuit current output.

KEYWORDS: piezoelectric polymer · nanoribbon · fiber drawing · PVDF · energy harvesting · ab initio calculation

tilization of the unique material properties represented by flexible, lightweight and biocompatible piezoelectric polymeric materials such as poly(vinylidene fluoride) (PVDF)<sup>1</sup> and its copolymer poly(vinylidene fluoride trifluoroethylene) (PVDF-TrFE)<sup>2</sup> is expected to bring on new horizons for sensor, actuator, and energy harvesting applications where piezoelectric ceramic materials have been employed hitherto. A closer look into the applications of piezoelectricity including biosensing,<sup>3</sup> energy generation,<sup>4–6</sup> pressure sensing,<sup>7</sup> high precision positioning,<sup>8</sup> artificial muscle and skin<sup>9,10</sup> reveals that thermally stable, flexible, and stretchable piezoelectric materials are required to be produced with high yields and in a cost-effective way for the fabrication of commercially feasible, large area, self-powering, and highly efficient devices. Although ceramic piezoelectric materials

can present higher piezoelectric coefficients, they suffer from high brittleness, low cyclic endurance, high processing temperature and high production cost as well as toxic elemental composition in contrast to properties of polymer piezoelectric materials.<sup>11,12</sup>

Since the discovery of PVDF (CH $_2$ –CF $_2$ ) $_n$ , which has the highest piezoelectric coefficient among all polymers,  $^1$  PVDF and copolymers have been a subject of intense research, which initiated development of many fabrication methods for PVDF thin film $^{13}$  and nanowires.  $^{14}$  Regardless of the production method, piezoelectric properties are dependent on the amount of polar phase of PVDF.  $^{15,16}$  Four commonly known forms of PVDF are  $\alpha$ ,  $\beta$ ,  $\gamma$  and  $\delta$  phases, which are represented by different stereochemical structures with alternating s-trans and s-gauge C–C bonds (TGT $\bar{\rm G}$ , TTT, TTTGTTT $\bar{\rm G}$ , and TGT $\bar{\rm G}_{({\rm polar})}$ ), respectively.  $^{15,17}$ 

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The most stable and easily obtained form of PVDF is the nonpolar  $\alpha$  phase, which can also be in a rarely found polar form named  $\delta$  phase. On the other hand,  $\beta$  and  $\gamma$ phases are the most desirable forms of PVDF due to their high polar molecular conformations. 14,18-21 High polarity of the  $\beta$  phase as a result of all trans C—C bonds makes PVDF a promising candidate for piezoelectric, pyroelectric and ferroelectric applications.7,14,18,19 Transitions between phases of PVDF are possible under specific nucleation and processing conditions (Figure S1, Supporting Information (SI)). Irrespective of the initial phase, the amount of the  $\beta$  phase in PVDF thin films can be increased by adding inorganic additives or stretching more than 80% at 95 °C following with an electrical poling. 15,22 Transition mechanisms resulting in  $\gamma$  phase are crystallization at high temperature or applying high shear on molten polymer, long-term annealing at high temperature or polling at low electric field from  $\alpha$  phase, and low rate evaporation from high temperature polymer solutions.  $^{16,20,21,23}$  Although,  $\gamma$ phase has lower polarity when compared to  $\beta$  phase, its piezoelectric coefficient still stands better than those of other polymers. 17,20 Besides, the higher Curie temperature of  $\gamma$  phase makes it less vulnerable to harsh environmental conditions. Because of the decay of remnant polarization of  $\beta$  phase PVDF and PVDF-TrFE at lower Curie temperatures, these materials are not good candidates for production of thermally stable long endurance devices.<sup>24</sup> Because of its superior properties,  $\gamma$  phase is highly desirable. Unfortunately, it is known to be hard to access experimentally.<sup>20</sup>

The most common way of triggering polar phase transitions is applying a high strength electric field at elevated temperatures. 14,25,26 In addition, diminishing the feature size of PVDF lowers the cost and energy required for the polarization process.<sup>27</sup> In accordance with the developments in nanotechnology, scientists have been trying to facilitate nanoscale effects to improve the piezoelectric properties of PVDF and copolymers by altering their composition, <sup>21,22,28,29</sup> size and shape. 18-20,23,27,30,31 Initial attempts were focused on developing PVDF piezoelectric thin films by using spray coating,<sup>32</sup> spin coating,<sup>17</sup> physical vapor deposition,33 and the Langmuir-Blodgett thin film coating methods.34 Although shaping the PVDF in the form of thin film can disclose elevated piezoelectric properties, PVDF nanowires lead to superior piezoelectricity, due to the one-dimensional nanoscale confinement.<sup>7,14</sup> Results of nanoconfinement effects such as spontaneous polarization can eliminate external electrical poling process for polar phase transition. 19,20,31

Beyond the controversy, nanowires have made great impacts on many disciplines including solar cells, biosensors and phase change memory devices.<sup>35–38</sup> A similar impact is also expected on piezoelectric applications using PVDF nanowires. The prominent piezoelectric PVDF nanowire fabrication methods are

anodized alumina (AAO) template molding, 19,20,39 electrospinning, 7,14,40,41 and nanoimprint lithography (NI), 18,23,27,31 which are all solvent dependent. Even though these techniques are appropriate to produce PVDF nanowires, they are not superior in all aspects considering the nanowire aspect ratio, uniformity, geometry control, yield, and device integrability in order to produce large area, low cost and high throughput devices (Table S1 (SI)). Despite the fact that high aspect ratio nanowires can be produced with high yield by using electrospinning, diameter uniformity and geometry control capability of this technique are not fulfilling the requirements of current state of the art technology. Tuning the diameter of nanowires can be better accomplished by using AAO and NI techniques. However, nanowires produced by these methods are not feasible to carry out the production of flexible, large area devices. Above all, unlike electrospinning, AAO, and NI techniques, a fabrication technique that provides PVDF nanowire production with high aspect ratio, excellent uniformity, desired geometry, and high yield in a multimaterial fashion can pave the way for in situ assembly of nanowires with metallic, semiconductor and dielectric components of the macroscopic devices. 42,43

# **RESULTS AND DISCUSSION**

Compatibility of iterative fiber drawing based size reduction technique for a wide range of materials in nanowire shape has been demonstrated. 43-45 On the contrary to a recent study, 46 it is possible to produce micro- and nanostructured PVDF in polar phase spontaneously induced by fiber drawing process as we showed in this study for the first time. Here, we produced kilometer-long, PVDF arrays in novel forms such as nanoribbon and square cross-sectional nanoshell (Figure S2 (SI)) structures. We rather prefer ribbon shape with planar contact areas, which poses a unique advantage for piezoelectric measurements, unlike the nanowires with cylindrical symmetry. We achieved highly polar  $\gamma$  phase PVDF nanoribbons from the fiber drawing technique simultaneously utilizing high temperature and shear stress triggered by tensile forces (Figure S3 and Video S1 (SI)). In order to simulate the phase transformation in iterative fiber drawing process, we performed ab initio calculations based on density functional theory in which the effects of both temperature and shear stress are included. The details of the method are explained in the Supporting Information. We compared the phase transition at 0 and 470 K (above the melting temperature of PVDF) from  $\alpha$ and  $\beta$  phase to  $\gamma$  phase under varying compressive and tensile strain.  $\gamma$  phase in the as produced PVDF nanoribbons is observed to still exist after annealing at high temperatures up to 175 °C.  $\alpha$ ,  $\beta$  and  $\gamma$  phase distribution in PVDF ribbons are investigated as a function of size using X-ray diffraction (XRD) and attenuated total

reflectance—fourier transform infrared (ATR—FTIR) spectroscopy techniques. PVDF ribbons are confirmed by morphological characterizations conducted with scanning electron microscopy (SEM). Using a piezo evaluation system attached to an atomic force microscope (AFM), we observed a large piezoelectric response ( $d_{33}$ = -58.5 pm/V) from a single 80 nm thick nanoribbon. To our knowledge, this is the first piezoelectric measurement performed on a single PVDF nanoribbon. Besides, here we report the highest effective  $d_{33}$  coefficient ever measured from a  $\gamma$  phase single PVDF nanoribbon. To utilize the superior performance, we designed two different device structures for the purpose of energy harvesting and tapping sensor. Peak voltage and current outputs of our devices are measured as 60 V and 10  $\mu$ A.

The nanoribbon fabrication procedure starts with preparation of a multimaterial preform, which is an exact macroscopic copy of the final fibers. The easiest way to produce a preform is rolling polymer films, degassing the air trapped in the roll under a vacuum at a temperature below the glass transition temperature of the films and last consolidating in a vacuum oven at the glass transition temperature of the films. Following the mentioned procedure, a PVDF preform is prepared by rolling 60  $\mu$ m thick PVDF films around a glass tube and consolidated in a tube oven at 180 °C for 30 min under a 2  $\times$  10<sup>-2</sup> Torr vacuum. Next, a slab (3 mm  $\times$ 10 mm  $\times$  10 cm) is mechanically extracted from this PVDF preform. Afterward, a poly(ether sulfone) (PES) preform with 35 mm in diameter and 25 cm in length is made by rolling 100  $\mu$ m thick PES films around a 3 mm glass tube and consolidated at 255 °C for 35 min under a  $2 \times 10^{-2}$  Torr vacuum. The PES preform is split in two halves and machined in the center to open a niche for inserting the PVDF slab (Figure 1a).

Fiber drawing processes are executed in a custommade fiber tower, which consists of a vertical tube oven, a preform feeding mechanism, and a real time monitoring system measuring applied stress, temperature, and thickness of the drawn fiber (Figure S4 (SI)). Figure 1b summarizes the nanoribbon fabrication technique. The fabrication of PVDF nanoribbon arrays, which comprises several fiber drawing steps, starts with the drawing of PVDF slab embedded PES preform. Heating the preform above the glass transition temperature of PES and melting point of PVDF and applying approximately 3 MPa tensile stress are required in order to trigger plastic deformation in fiber drawing process. Since drawing temperature (285 °C) or the temperature in the core of the preform (~200 °C) is higher than the melting point of PVDF ( $T_{\rm m} = 165$  °C), the molten slab flows and shrinks in the PES cladding during fiber drawing. The first step of thermal drawing process results in PVDF microribbons with various thicknesses ranging from 400 to 10  $\mu$ m by adjusting the process temperature, applied stress, drawing and

feeding speed. Figure 2a shows as drawn step 1 fibers and Figure 2b represents cross sectional and longitudinal SEM images of 30  $\mu m$  thick microribbon embedded fibers, which are produced in the first step with a preform feeding speed 8 mm/sec. For the second drawing step, approximately 400 first step fibers are stacked and inserted into cylindrical hollow core of a new PES preform, which becomes a multifunctional jacket protecting and keeping the PVDF nanoribbons together. Sequential thermal drawings of the preform prepared for the second step result in thicknesses ranging from 300 to 50 nm (Figure 2c,d). Similarly, 400 nanoribbon embedded fibers obtained in previous steps are inserted in new PES preforms produced for the third step fiber drawing processes. After drawing the third step preform, nanoribbons result in thicknesses ranging from 50 to 5 nm (Figure 2e,f). We extracted PVDF nanoribbons out of the PES cladding by using dichloromethane (DCM), which cannot dissolve PVDF. Cross sectional characterization of nanoribbons requires a special sample preparation using ultramicrotome for SEM imaging. However, diamond knife of the ultramicrotome causes defects that hamper observing the exact cross sectional shape of the nanoribbons. In addition, even though state of the art electron microscopy techniques are used, imaging of nanometer scale polymer features is very difficult due to fast degradation of polymers under high energy electron beam.<sup>47</sup> Alternatively, a better SEM observation of the ribbon shape is accomplished using two different sample preparation methods: breaking the fibers after a liquid nitrogen treatment (Figure S5 (SI)) and direct cutting of the fibers longitudinally (Video S2 (SI)). Size distribution for second step PVDF nanoribbons is given in Figure S6 (SI). Standard deviation normalized with respect to the mean of the nanoribbons size distribution is found to be  $\sim$ 11%.

The distance between nanoribbons is well-defined with cladding thicknesses of the input fibers. In addition, the macroscopic encapsulation polymer makes it practicable to manually manipulate kilometers long, perfectly aligned, millions of nanowires. Number and total lengths of the nanoribbon embedded fibers are progressive in conformity with the growing number of drawing steps. For instance, despite that a 200 m long in-fiber single ribbon is obtained after the first step drawing, nanoribbons are achieved in kilometers of length and thousands of number in following drawing steps. Dimensions of the first step slab and preform, overall reduction ratio, and the number of steps in iterative fiber drawing processes determine the final size of nanoribbons. Besides, ribbon shape is inherited by next generation ribbons from the fibers produced in previous steps.

Molecular conformation of  $\alpha$ ,  $\beta$  and  $\gamma$  phases are shown in Figure 3a. Predominance of the polar  $\gamma$  phase

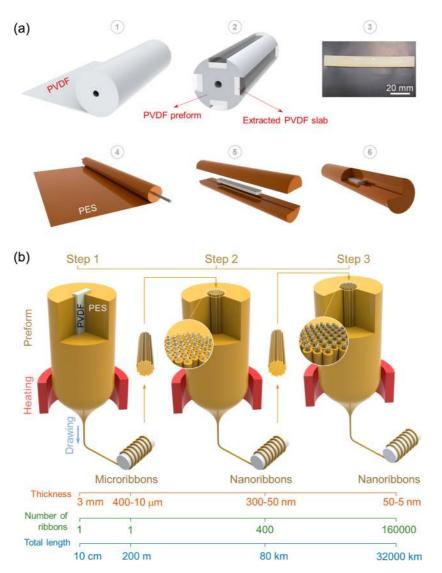


Figure 1. A novel top-to-bottom nanofabrication technique for producing kilometer-long piezoelectric nanoribbons. (a) The fabrication steps of the PVDF ribbon embedded in PES preform, which is a macroscopic copy of the final nanoribbons. As an initial step, (1) a PVDF preform is built by rolling PVDF sheets, and (2–3) a slab is mechanically extracted out of the PVDF preform. (4–5) Next, the PVDF slab is inserted into a PES preform, which is then sealed by heating in a consolidator oven. (6) The final multimaterial product turns into a PVDF ribbon embedded PES matrix. Dimensions and design specifications of the preform directly affect the size and shape of the final product of the drawing process. (b) An iterative fiber drawing scheme allows to achieve nanometer structures. A macroscopic PVDF slab is inserted, thermally sealed in a PES matrix, and drawn thermally to produce first step fibers. At high temperatures, molten PVDF flows together with softened PES cladding, producing tens of meters long PVDF microribbon encapsulated in PES. First step fibers are stacked and redrawn in a new preform for the second step fiber drawing in order to decrease the size of the ribbons down to nanometers. Further size reduction can be accomplished by following same stacking and redrawing cycles. From the first step to the last step, total number and length of the ribbons in the fiber increase as the size of each nanoribbon decreases.

ribbons produced in first, second, and third drawing steps is clearly observed by using XRD. PES claddings of nanoribbons are etched in DCM before XRD measurements in order to eliminate amorphous background arising from the PES cladding, and to increase the signal intensity. In the literature, characteristic peak positions (2 $\theta$ ) of PVDF are tabulated as 17.7°, 18.4°, 19.9°, 26.5, 27.8°, 35.7°, 39°, and 57.4° for  $\alpha$  phase; 20.7°, 20.8°, 35°, 36.6°, and 56.1° for  $\beta$  phase; 18.5°, 19.2°, 20.1°, 20.3°, 26.8°, 36.2°, and 38.7° for  $\gamma$  phase. 15.16,20,21 Starting from the PVDF macroscopic slab, we have analyzed change of phase content for all

fabrication steps (Figure 3b). The slab includes a minor amount of  $\beta$  ( $2\theta$  = 20.7°) and  $\alpha$  ( $2\theta$  = 27.8°) phases, and a transition trend to the  $\gamma$  phase is persistent starting from the first step ribbons. Although suppressed  $\alpha$  phase peaks still exsit at 17.7°, 26.5° and 27.8° peak positions, dominance of the  $\gamma$  phase is obvious from the peaks at  $2\theta$  = 18.5°, 20.1° and 26.8°. For the second step nanoribbons, except shifts observed in  $\gamma$  peak positions from 20.1° to 20.3°, and 18.5° to 18.6°, other peaks preserve their positions. Characteristic peaks of  $\gamma$  phase in the third step nanoribbons are located at the same peak positions of the first step microribbons.

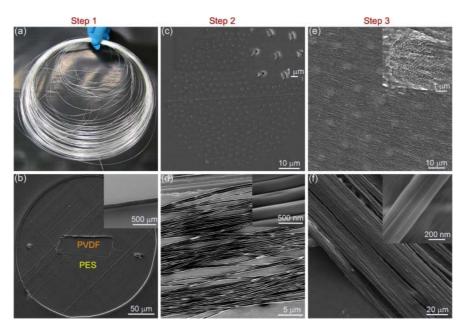


Figure 2. SEM micrographs of PVDF micro- and nanoribbons produced by using iterative size reduction technique in each drawing step. (a) Photograph of tens of meters long PDVF nanoribbon array embedded in PES cladding. (b) Cross sectional image of first step PVDF microribbon in the PES cladding. Inset: Free-standing PVDF microribbon obtained by etching PES cladding using chemical etchants. (c) Cross sectional image of second step fiber with  $\sim$ 400 nanoribbons. Inset: Close-up image of nanoribbons. (d) Lateral image of second step nanoribbons. Inset: Close-up image of aligned nanoribbons. (e) Cross sectional image of third step nanoribbon bundles in fiber. Close-up image of a single bundle. (f) SEM of third step nanoribbons extracted out of their cladding. Inset: Close-up image of aligned nanoribbons.

Broadening in the  $\gamma$  phase peaks and drastic fall in  $2\theta$  = 26.8° peak intensity indicate a slight decrease in amount of  $\gamma$  phase in step 2 and 3.

Another tool that we used for analyzing and confirming the phase distribution in nanoribbons is ATR-FTIR. Absorption band characteristics of  $\alpha$ ,  $\beta$ , and  $\gamma$  phases of PVDF are identified as given in literature: 532, 612, 763, 796, 854, 870, 974, 1146, 1210, 1383, and 1423 cm $^{\circ}$  for  $\alpha$ ; 510, 840, 1279, 1286, 1431 cm $^{\circ}$  for  $\beta$ ; 812, 833, 838, 885, and 1234 cm $^{-1}$ bands for  $\gamma$ . However, most of the absorption bands are superimposed for  $\beta$  and  $\gamma$  phases hindering the phase discrimination.<sup>21</sup> Overlapping peak at 840, 1279, and 1286 cm<sup>-1</sup> with  $\gamma$  and  $\beta$  phases can be assigned for  $\gamma$  phase as long as no  $\beta$  peak is identified using XRD technique for micro- and nanoribbons. Figure 3c represents ATR-FTIR absorption spectra for PVDF nanoribbons produced in all steps. Fraction of the  $\gamma$  phase is calculated using the following equation:

$$F(\gamma) = \frac{X_{\gamma}}{X_{\alpha} + X_{\gamma}} \times 100 = \frac{A_{\gamma}}{(K_{\gamma}/K_{\alpha})A_{\alpha} + A_{\gamma}} \times 100 \quad (1)$$

where the  $X_{\gamma}$  and  $X_{\alpha}$  are degree of crystallinity,  $A_{\gamma}$  and  $A_{\alpha}$  are measured absorbance intensity,  $K_{\gamma}$  and  $K_{\alpha}$  are wavelength dependent absorption coefficient and  $F_{\gamma}$  is the percentage of  $\gamma$  phase. We calculated  $\gamma$  percentage for 763 cm<sup>-1</sup>  $\alpha$  peak and 833 cm<sup>-1</sup>  $\gamma$  peak using corresponding absorbance coefficients  $K_{\gamma}=0.150$   $\mu$ m<sup>-1</sup> and  $K_{\alpha}=0.365$   $\mu$ m<sup>-1</sup> (Beer — Lambert Law), respectively.<sup>20,21</sup>  $\gamma$  phase percentage in step 1 microribbons is 76%, whereas step 2 and step 3 nanoribbons

 $\gamma$  phase percentage decreased to 72% as a result of diminishing shear force on nanoribbons exposed to heat retreatment with smaller cross sectional areas. <sup>48</sup>

Because of phase transformation into  $\gamma$  phase occurs at high temperatures, stability of the  $\gamma$  phase at harsh conditions needs to be investigated. We realized from sequential heat treatments to PVDF nanoribbons that  $\gamma$  phase PVDF produced by iterative fiber drawing technique is quite stable at high temperatures. Nanoribbons extracted out of the PES cladding are annealed at several different temperatures up to 175 °C, and it is evident from XRD peaks that there is no significant change in  $\gamma$  phase content (Figure 3d). It is clearly observed from the peaks at  $2\theta=18.6^\circ$ , 20.1° and 26.8°,  $\gamma$  phase still exists at elevated temperature. Regarding broadening and decreasing intensity of XRD peaks, we observed that crystallinity is slightly diminished due to effect of high temperature.

Structural changes due to temperature and induced stress during the fiber drawing is investigated by *ab initio* calculations, which confirm that there is a phase transition trend from  $\alpha$  and  $\beta$  forms to  $\gamma$  form under tensile and compressive strain (Figure 3e–g, Figure S7 and Video S3 (SI)). The temperature in the simulation is set to 470 K, which corresponds to PVDF core temperature during drawing process (Figure S8 (SI)) and which also is well above the melting temperature of PVDF. For comparison and to understand the effect of temperature, the calculations are also performed at 0 K (which actually corresponds to the case where temperature effects are excluded in *ab initio* simulations to

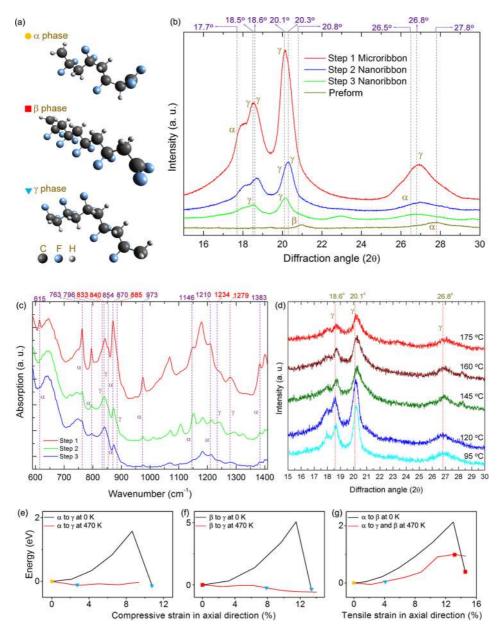


Figure 3. XRD and ab initio simulation results representing  $\gamma$  phase transition from PVDF slab via fiber drawing process. (a) PVDF has three main forms, which are known as nonpolar  $\alpha$  phase, polar  $\beta$  and  $\gamma$  phases. (b) XRD data of PVDF slab extracted from a preform, microribbon and nanoribbon are taken after removing the PES cladding. Peaks observed at 18.5° and 18.6°, 20.1° and 20.3°, 26.8° correspond to the planes of  $\gamma$  polar form (020), (002)/(110) and (022), respectively.  $\alpha$  phase peaks at 17.7° 26.5° and 27.8° are collected from (100), (021) and (111) planes. Peak at 20.8° is the only  $\beta$  peak observed in the slab. Spontaneous polar form ( $\gamma$  phase) is achieved after the thermal size reduction in all fiber drawing steps. (c) ATR-FTIR peaks from the first, second and third step PVDF microribbons and nanoribbons representing  $\alpha$  and  $\gamma$  phases. 833, 840, 885, 1234, 1279, and 1286 cm<sup>-1</sup> are characteristics of the  $\gamma$  phase PVDF. 615, 763, 796, 854, 870, 973, 1146, 1210, and 1383 cm<sup>-1</sup> are the FTIR peaks of  $\alpha$  phase PVDF. Fraction of the  $\gamma$  phase is 74% in first step microribbons whereas it decreases 72% in third and second step nanoribbons. (d) XRD patterns showing the characteristic peaks of the second step PVDF nanoribbons at different annealing temperatures. Although the temperature is increased above the melting point of PVDF, dominance of  $\gamma$ phase is obvious from the peaks at 18.6°, 20.1° and 26.8° positions. (e) Transition from  $\alpha$  (yellow circle) to  $\gamma$  phase (blue triangle), (f) transition from  $\beta$  (red square) to  $\gamma$  phase with compressive strain and (g) transition from  $\alpha$  to  $\beta$  phase with tensile strain on the unit cell with 6 monomers of PVDF in axial direction are simulated considering fiber drawing parameters (high temperature and shear stress) using ab initio calculations. 0 K results are corresponding to the case where temperature effects are excluded.

obtain ground state properties). The applied force in the fiber drawing axis causes stretching in the same direction but compression in the perpendicular directions. As the orientation of the molecules with respect to fiber drawing axis in the bulk PVDF can vary, all strain components that occurred during the fiber drawing should be taken into account in the *ab initio* model in which we considered tensile and compressive strains in the system as lattice stretching and lattice compression, respectively. The results are summarized in

Figure 3e-g, where yellow circle, red square and blue triangle represent the molecular chains in Figure 3a. When compressive strain is applied in axial direction of  $\alpha$  and  $\beta$  form PVDF, a transformation from  $\alpha$  to imperfect  $\gamma$  phase with longer nonpolar parts, and a transformation from  $\beta$  to ideal  $\gamma$  phase are clearly observed at both 0 and 470 K. Although a very high activation energy of 1.6 and 5.1 eV, which practically makes the transformation impossible, is required at 0 K for the transition from  $\alpha$  and  $\beta$  to  $\gamma$  phase, respectively, the same phase change phenomena occur with almost no energy barrier at 470 K. The required strain for phase transformation is significantly reduced with temperature as well. While transformations from  $\alpha$  to  $\gamma$  occurs at 10.8% and  $\beta$  to  $\gamma$  at 13.4% compressive strain at 0 K, the same transformations are observed at 3 and 8% at 470 K. The similar trends are observed at higher temperatures with a small amount reduction in the required strain (Figure S9 (SI)). These results indicate that the temperature above the melting point of PVDF during the fiber drawing process enables the phase transformation from other phases to  $\gamma$  phase by decreasing the required compressive strain and energy barrier. The peaks obtained at  $2\theta = 17.7^{\circ}$ ,  $26.5^{\circ}$  and 27.8° from XRD data, which correspond to  $\alpha$  phase PVDF as shown in Figure 3b, can be explained by imperfect transformation from  $\alpha$  to  $\gamma$  phase. In a similar manner, tensile strain in axial direction is also applied. A direct phase transition from  $\alpha$  to  $\beta$  phase is favored at 0 K when strain exceeds 14.6%, and the required activation energy is 2.1 eV. Interestingly, when the temperature is elevated up to 470 K or more, instead of direct transition from  $\alpha$  to  $\beta$  phase,  $\gamma$  phase appears in the first place at 2.2% transforming into a perfect  $\gamma$ phase at 4.4% of tensile strain with an energy barrier of 0.07 eV. If strain is further increased and reaches 13.1%, imperfect  $\beta$  phase can be obtained with an energy barrier of 1.0 eV (the imperfection of the  $\beta$  phase can be due to the requirement of polarization process for the transformation 15). Therefore, simulation results show that energy barrier for  $\alpha$  to  $\gamma$  transition (0.07 eV, blue triangle in Figure 3g) under tension is lower than  $\alpha$ to  $\beta$  transition (1 eV, red square in Figure 3g) under tension.

Electrical characterizations such as piezoelectric displacement and ferroelectric hysteresis curve measurements are performed for PVDF nanoribbons. Utilizing a (Radiant Premier II) piezoelectric evaluation system along with an AFM instrument simultaneously functioning as a high precision displacement sensor and a tool for electrical coupling to nanoscale surfaces (Figure S10 (SI)), a large average effective piezoelectric coefficient ( $d_{33}$ = -58.5 pm/V) is measured from 80 nm thick, 180 nm wide single PVDF nanoribbons isolated from an as-produced bundle (Figure 4a). As the exact shape and the size of the tip is unknown, we can only represent a ferroelectric hysteresis curve (polarization vs

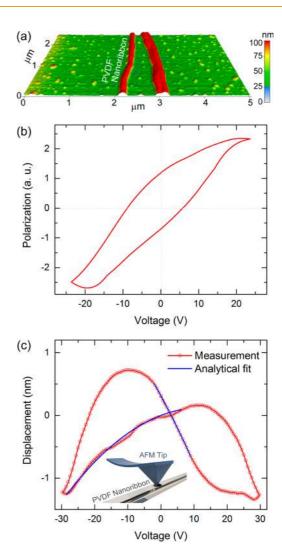


Figure 4. (a) AFM topography of 80 nm thick and 180 nm wide single and double nanoribbons on a metal coated substrate. (b) Hysteresis loop of as produced single nanoribbons at 25 V and 100 Hz, which represents the spontaneous electric polarization. (c) Displacement—voltage hysteresis loop taken by an AFM and piezoelectric evaluation system from a single PVDF nanoribbon. Inverse butterfly loop is a characteristic result of the negative  $d_{33}$  piezoelectric coefficient. Total measured displacement is a function of E and  $E^2$ . Since the applied electric field and displacement are known,  $d_{33}$  and Q values can be calculated in least-squares sense. Data fitting is executed by using 370 data points.

voltage) in arbitrary polarization units. But still remnant polarization can clearly be observed (Figure 4b). Since PVDF is a multiferroic material and piezoresponse characterization of nanoscale piezoelectric materials is challenging, characterization of PVDF nanoribbons is inherently multiphysical problem that requires considering internal and external variables such as local temperature changes, electrostriction, pyroelectricity, ferroelasticity, electrostatic effects, indentation regime, applied electrical potential, contact (AFM Tip) sliding and drifting effects. Piezoelectric coefficient measurements using AFM and a piezoelectric evaluation system (virtual ground mode) can be well understood in three

sequential stages: sample preparation and mechanical contact with AFM tip, recording piezoelectric response, analyzing the acquired signals for calculating pure piezoelectric displacement. The ribbon structure provides convenience for piezoelectric measurements with AFM since a more conformal contact between the bottom of the nanoribbon and the conductive surface of the substrate diminishes the sliding and drifting adversities during measurements. Before local piezoelectric characterization, we operated a noncontact mode AFM surface imaging for locating a PVDF single nanoribbon among dispersed nanoribbons on a 60 nm silver coated silicon wafer. After a mechanical contact between AFM tip and the surface of the nanoribbon is accomplished in contact mode AFM, we conducted displacement-voltage (D-V) measurements applying 10 ms bipolar triangular voltage pulses between the AFM tip (electrical potential) and the metal coating of the substrate (ground). During piezoelectric measurements, we kept AFM control loop off and recorded piezoelectric displacements in a very short time scale compared to that of AFM tip drift. In addition, we used multiple deflection measurements from each local contact surface and calculated the average D-V curve in order to analytically cancel drifting effects and calculate a more accurate piezoelectric coefficient. AFM is one of the most precise deflection sensors that can dynamically detect the change in the thickness of PVDF nanoribbons according to alternating electric potential. However, many artifacts can occur related to applied electric field and contact indentation regime during piezoelectric measurements at nanoscales. We used experimental and analytical approaches in order to eliminate such effects and analyze the origin of the large displacement in PVDF nanoribbons. First, electrostatic forces can dislocate AFM tip in nanoscale distances. This effect can be simply eliminated using a stiffer (k = 40 N/m) and f = 300 kHz) AFM tip. Measured signal from AFM deflection corresponds to the change in the thickness of PVDF nanoribbon because, in principle, AFM tip follows the surface motions of the sample. From the mechanics of materials perspective, we can calculate the total strain ( $s = \Delta t/t$ ) in PVDF nanoribbons, where t is the thickness of the nanoribbons and  $\Delta t$  is the measured change in the thickness. The measured strain is not a pure piezoelectric deflection, but rather a sum of strain components caused by electrostriction, thermal effects and applied pressure in the direction of the electric field.

$$s = s_{piezoelectric} + s_{electrostriction} + s_{thermal} + s_{pressure}$$
 (2)

$$s = d_{33}E - QE^2 + \lambda \Delta T + e_{33}\sigma_{33}$$
 (3)

where  $d_{33}$  is the piezoelectric coefficient, E is the electric field, Q is the electrostriction coefficient,  $\lambda$  is the thermal expansion coefficient,  $\Delta T$  is the change in the

temperature,  $e_{33}$  is the elastic coefficient and  $\sigma_{33}$  is the stress. The pressure induced strain related to indentation regime or AFM tip can trigger ferroelastic motions in PVDF nanoribbons, unless the indentation force is very small and constant. Since we need to apply a voltage to our conductive tip, it is required to make a mechanical contact with the surface of the nanoribbons. A COMSOL Multiphysics simulation is designed to analyze the deformation of contact region during piezoelectric measurements (Figure S11 (SI)). The simulation results show that applying a -60 nN indentation force on the 80 nm thick PVDF nanoribbon, which corresponds to 15 nm static deflection in AFM cantilever, triggers maximum 0.3 nm elastic deformation on the surface with an AFM tip diameter of 10 nm. Therefore, AFM tip is guaranteed to be in constant mechanical contact with the nanoribbon surface during measurements, due to AFM tip deflection range is higher than the total piezoelectric displacement measured. Dilatation of PVDF nanoribbons and pyroelectric effects can also be ignored, because all measurements are conducted at constant room temperature. In addition, to consider the local temperature changes caused by joule heating, we modeled the change in the PVDF nanoribbon temperature as a function of the electric potential (Figure S12 (SI)). Joule heating is proportional to  $i^2$  and R, where i is the traveling current across the PVDF thickness and R is the resistance. Since resulting current is very small, there is no change in the temperature caused by joule heating. Experimentally eliminating the pressure and temperature dependent strain components results in eq 4.

$$s = d_{33}E - QE^2 \tag{4}$$

Inserting the measured data (displacement vs applied field) in eq 4, an overdetermined system of equations for two unknowns ( $d_{33}$  and Q) is obtained, which can be solved in least-squares sense as shown in the Supporting Information. Results are perfectly fitted to the measured curve (Figure 4c). We calculated that electrostriction and piezoelectric coefficient of  $\gamma$  phase PVDF nanoribbons are  $Q = -67.8 \times 10^{-9} \text{ pm}^2/\text{V}^2$  and  $d_{33} = -58.5$  pm/V. In the range of a maximum  $\pm 10$  V applied electric potential difference, 87.4% (585.3 pm) and 12.6% (84.47 pm) of the deflection result from pure piezoelectric effect and electrostriction, respectively. The measured average effective piezoelectric coefficient of  $\gamma$  phase PVDF nanoribbons is higher than the reported values of  $\beta$  phase ( $d_{33} = -30$  pm/V) and  $\gamma$ phase ( $d_{33} = -7 \text{ pm/V}$ ) PVDF thin films, <sup>15,21</sup> and on same order of magnitude with  $\beta$  phase ( $d_{33} = -57.6$  pm/V) PVDF nanowires, which are characterized in a similar manner using AFM.<sup>49</sup> Unlike the nanoribbons, the effective  $d_{33}$  coefficient for thin films is expected to be reduced, due to surface clamping boundary conditions. 50 The reverse form of D-V hysteresis loop (Butterfly Loop) is due to the negative value of

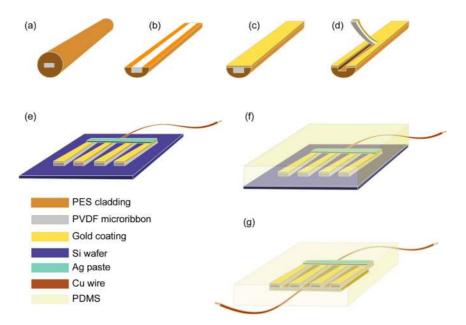


Figure 5. Fabrication process for the device produced using first step microribbons. (a) A 50  $\mu$ m thick microribbon embedded single fiber is selected. (b) The fiber is longitudinally divided in two pieces. (c) The surface of the piece with the ribbon trapped is coated 50 nm gold. (d) After carving the PVDF microribbon out of the cladding, it is cut in equal pieces. (e) One side coated microribbons are aligned on a silicon substrate. Next, Ag paste and Cu wire electrodes are attached on the gold coated surface of the microribbons. (f) The structure is transferred onto a PDMS layer. (g) The back side of the PVDF microribbons are also coated with 50 nm gold, and the whole device is embedded in PDMS.

 $d_{33}$  coefficient (Figure 4c). The general relation between piezoelectric coefficients of PVDF is  $d_{33} \ge d_{31} >$  $d_{32} > 0.^{30,48}$  In order to confirm the measurent technique, we conducted the same measurement on  $\boldsymbol{\alpha}$ phase commercial PVDF thin film with 60  $\mu$ m thinckness, 25  $\mu$ m<sup>2</sup> surface area, and we observed no significant deflection as expected.

We developed two devices with different geometries using PVDF micro- and nanoribbons produced by thermal size reduction technique. In the first device, a first step fiber is longitudinally divided in two halves without damaging the PVDF microribbon and one face of the microribbon PVDF is uncovered. 50 nm gold is sputtered on the open surface of the microribbon. After mechanically removing the remaining part of PES cladding, the microribbon is cut in smaller pieces and aligned on a silicon substrate, so that the gold deposited faces are on the top. A contact pad is attached to the gold coated surface of 50  $\mu$ m thick PVDF microribbons, and the structure is transferred onto a polydimethylsiloxane (PDMS) layer which avoids the short circuit of the device and maintains the alignment of the microribbons. Subsequently, the other surfaces of the microribbons are also coated with 50 nm thick gold, and whole device is embedded in PDMS (Figure 5a-g). The second device with a different structure convenient for nanoribbons is fabricated using 300 nm PVDF ribbons, which are extracted out of the PES cladding using DCM. The both side of the nanoribbon bundles are coated with sputtering of 50 nm gold film using a shadow mask (Figure S13 (SI)). Misalignment of nanoribbons is expected to be reduced

output voltage and current of the device. Effective area of the devices fabricated using microribbons (Figure 6a) and nanoribbons (Figure 6b) are 100 mm<sup>2</sup> and 20 mm<sup>2</sup>, respectively. Characterizations of the devices are carried out with an external load capacitance ( $C_1 = 16 \text{ pF}$ ) and resistance ( $R_L$  =10 M $\Omega$ ). An equivalent circuit (Figure 6c) for piezoelectric devices can be represented by a parallel RC circuit containing a charge source (q), a resistor  $(R_0)$ , capacitor ( $C_0$ ). From DC and impedance measurements (Figure S14 (SI)), internal resistor ( $R_0$ ) and capacitor ( $C_0$ ) for the first and second device are calculated to be  $R_0$  = 100 G $\Omega$  and  $C_0$  = 3.4 pF,  $R_0$  = 40 G $\Omega$  and  $C_0$  = 4.6 pF, respectively.

Because of PVDF dipoles oriented perpendicular to the fiber axis, when a force is applied vertical to the fiber axis, a positive piezoelectric potential is produced and collected on positive electrode. The same phenomenon occurs vice versa during the releasing. Output voltages and currents of the devices are recorded under quasi-periodic tapping forces (Video S4 (SI)). The output voltage and current are related to the magnitude and period of tapping force. The typical output values of the device fabricated using microribbons is 6 V and 3  $\mu$ A (Figure 6d,e), and the typical output values of the device produced using nanoribbons is 40 V and 6  $\mu$ A (Figure 6f,g). Although microribbons have 4% higher amount of polar phase content, charge collected from the device built with nanoribbons is approximately 9 fold higher due to greater contact surface area (2 orders of magnitude higher) and better charge collection efficiency of nanoribbons. Maximum output (60 V and 10  $\mu$ A for the nanoribbons, 7 V and

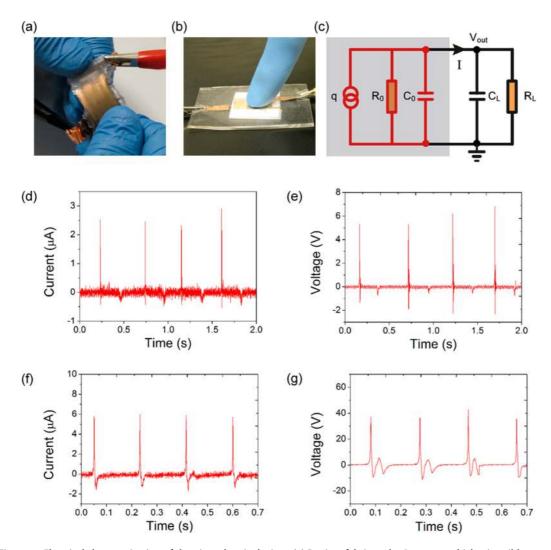


Figure 6. Electrical characterization of the piezoelectric devices. (a) Devices fabricated using 50 µm thick microribbons and (b) 300 nm thick nanoribbons. (c) A piezoelectric device can be modeled as a parallel RC circuit containing a charge source (q), resistor  $(R_0)$  and capacitor  $(C_0)$ , which is represented by red lines on gray background. The remaining part of the circuit  $(C_1)$  and  $R_{\rm L}$ ) belongs to an external load. (d) Current and (e) voltage output measurements of the device produced using 50  $\mu$ m thick PVDF microribbons. (f) Current and (g) voltage output measurements of the device produced using 300 nm thick PVDF nanoribbons.

3  $\mu$ A for the microribbons) of the piezoelectric devices can be seen from a broader range of the electrical measurements given in Figure S15 (SI). Besides, peak output power densities of first and second devices are 5.25 and 750  $\mu$ W/cm<sup>2</sup>, which prove that efficiency of the nanoribbons is much higher. We built another device using nonpiezoelectric amorphous As<sub>2</sub>Se<sub>3</sub> nanowires (150 nm in diameter) produced by thermal fiber drawing technique in order to confirm piezoelectric effect observed in our devices (Figure S16 (SI)). There is no response observed except noise from the nonpiezoelectric device, despite the device produced using PVDF nanoribbons can response even for small tapping forces.

## CONCLUSION

We introduced a novel top-down solvent free method for the production of dominantly  $\gamma$  phase onedimensional PVDF nanostructures. PVDF micro- and nanoribbons ranging from 100  $\mu$ m to 5 nm in thickness are produced by using iterative fiber drawing technique in three drawing steps. As-produced nanoribbons have an ultrahigh aspect ratio (km/nm), good uniformity with cross sectional ribbon geometry, high thermal stability, and high piezoelectric properties. XRD and FTIR results reveal that the  $\gamma$  phase is the dominant phase (72%) in all nanoribbons. The shear stress and high temperature applied during fiber drawing process favor the polar  $\gamma$  phase transition. Simulating the fiber drawing process using ab initio calculations, we confirmed that transformation into  $\gamma$ phase from other phases at elevated temperature above the melting point of PVDF is favorable. Moreover, PVDF nanoribbons are annealed at several different temperatures up to 175 °C, and XRD results show that  $\gamma$  phase still exists after annealing. Piezoelectric characterizations of single 80 nm thick nanoribbons

are accomplished by exploiting a piezo evaluation system and an AFM Instrument as a nanoscale probing tool. To our knowledge, we report the highest effective piezoelectric coefficient ( $d_{33} = -58.5 \text{ pm/V}$ ) measured from a  $\gamma$  phase PVDF single nanoribbon. In addition, we built two proof of principle devices using 50  $\mu$ m and 300 nm ribbons for the purpose of mechanical energy harvesting and tapping sensor application. Short circuit peak voltage and peak short circuit current outputs of the devices are measured up to 60 V and 10  $\mu$ A. Our devices can be used with an energy harvesting circuit (rectifier and storage capacitor with a switching element) in low power requiring applications. Because of the polymer encapsulation, nanoribbon arrays can be transferred on any substrate and chemically extracted out of their polymer jacket for further device integration such as piezoelectric nanoribbons on interdigitated metal electrodes. Iterative fiber drawing technique holds a huge potential due to the capacity for multimaterial (metal-piezoelectric-dielectric) coprocessing in order to produce building blocks for large area, flexible, lightweight, long endurance, costeffective piezoelectric devices such as artificial muscle and skin, smart textiles, and energy generators.

### **EXPERIMENTAL SECTION**

Preform Fabrication. Iterative fiber drawing technique requires the use of composite (multimaterial) preforms. We produced one PVDF and three PES preforms. PVDF films (Ajedium Films – Solvay Plastics) with a thickness of 60  $\mu$ m are used for the fabrication of PVDF preform, which is 30 mm in diameter and 20 cm in length. In degassing and consolidation process, the preform is held in a vacuum oven for 4 h at 140 °C under  $2 \times 10^{-2}$  Torr pressure and consolidated for 30 min at 180 °C under  $2 \times 10^{-2}$  Torr vacuum pressure. Finally a slab 3 mm in thickness, 10 mm in width and 10 cm in length is mechanically extracted from the preform to be inserted into the first step PES preform. PES preforms are produced using one side polished 100  $\mu m$  thick PES films (Ajedium Films). PES preforms are 35 mm in diameter, and 25 cm in length and inner diameters of preforms are 3 mm. In degassing and consolidation process, preforms are held in a vacuum oven for 4 h at 180 °C under  $2 \times 10^{-2}$  Torr pressure and consolidated for 35 min at 255 °C under  $2 \times 10^{-2}$  Torr vacuum pressure. The first step PES preform is different from the second and third step preforms: To insert the PVDF slab inside the first step PES preform, we splited the preform in two parts and machined both halves.

Iterative Fiber Drawing Process. Fiber fabrication process consists of three consecutive fiber drawing steps. 3 MPa tensile stress is applied during fiber drawing through the fiber drawing axis. The temperature used in fiber drawing is 285 °C, which is well above the glass transition temperature and melting temperature of PVDF. Optimized preform feeding speed is found to be 8 mm/sec. The thickness of the ribbons ranges between 400 to 10  $\mu$ m in the first step, 300 to 50 nm in the second step and 50 to 5 nm in the third step. Approximately 400 fibers are used in the second and third steps.

Morphological and Chemical Characterizations. SEM images are taken using FEI Quanta 200 FEG electron microscopy with low voltage-high contrast detector (vDS) under a vacuum at 6 ×  $10^{-4}$  Pa chamber pressure. We used 5 kV acceleration and 4 kV deceleration (bias) beam voltage within 4 mm working distance. Lateral PVDF nanoribbon images are taken after the PES cladding of fibers are etched using DCM and 4 nm Au/Pd conductive film is sputtered on to the surface. To obtain cross sectional images, a special sample preparation process is used. First, fibers are embedded in a resin (Technovit 7100). Using a Leica EMUC6 - EMFC6 Ultramicrotome with a dimond knife, fiber cross sections are smoothed after the cryogenic chamber of the ultramicrotome is cooled down to -125 °C using liquid nitrogen. Before SEM images are taken, 4 nm Au/Pd conductive film is coated on the smoothed surfaces. To enhance the electrical conduction, each sample is painted using silver paste. XRD patterns of PVDF ribbons are taken by Pananalytical X'pert Pro XRD with a diffraction angle  $2\theta$  scanned between 5 to 75 degrees using a step size of 0.01 degrees and a dwell time of 800 s per step. Thermo Scientific Nicolet 6700 FTIR with an ATR attachment is used for molecular confirmations. FTIR reflection data is obtained with a wavelength scan resolution of 0.482 cm and a total of 256 scan steps.

Ab Initio Calculations. In order to simulate the phase transformation in iterative fiber drawing process and investigate the effect of temperature, *ab initio* calculations based on density functional theory<sup>51,52</sup> are carried out using Vienna *ab initio* simulation package (VASP).53,54 To understand the effect of compressive and tensile strength,  $\alpha$ -,  $\beta$ , and  $\gamma$ -PVDF with 6 monomer chains in the unit cell is considered at temperatures equal to and higher than drawing temperature (470 K), which are compared with ground state results at 0 K. Exchangecorrelation energy is expressed by the generalized gradient approximation (GGA) using PBE functional.55 The projector augmented wave (PAW) potentials are used for each element with a kinetic energy cutoff of 500 eV.56 All structures are relaxed with simultaneous minimization of the total energy and the interatomic forces. The convergence on the total energy and force was set to  $10^{-5}$  eV and  $10^{-2}$  eV/Å, respectively. For high temperature calculations ab initio molecular dynamics is enabled where microcanonical ensemble is simulated with 1 fs time steps

Piezoelectric Characterization. We used Radiant Technologies Premier II precision multiferroic piezoelectric evaluation system along with Oxford Instruments—Asylum Research MFP-3D AFM System for piezoelectric characterizations of a single PVDF nanoribbon. PES cladding of 80 nm thick PVDF nanoribbons are etched using DCM and nanoribbons are extracted on a 60 nm silver coated Si substrate. Position of a single PVDF nanowire is detected by operating a noncontact mode AFM surface imaging. We kept AFM control loop off during piezoelectric measurements. A stiff AFM tip (k = 40 N/m and f =300 kHz) is used to execute accurate measurements. Polarization curve is measured at 100 Hz and up to 25 V. Deflectionvoltage curve measurements are accomplished by applying 10 milisecond bipolar triangular voltage up to 30 V. Drifting effects are eliminated by averaging multiple measurements. Pure piezoelectric coefficient, electrostriction coefficient and other effects are calculated using MATLAB 13.0 and equations are solved in least-squares sense as shown in the Supporting

Finite Element Simulations. Using the software SolidWorks 2013 Simulation, three-dimensional numerical finite element method is conducted to show the distribution of normal and shear stress when a 3 MPa triggerring stress is applied trough the fiber drawing axes for polymer materials. Effect of the gravity (9.81 m/s<sup>2</sup>) is also taken into account. Simulation temperature is considered constant at fiber drawing temperature (258 °C). To find out the yield characteristics in fiber drawing process, the maximum von Mises stress ( $\sigma_{\text{vonMises}}$ ) criterion, which is based on the von Mises-Hencky theory is appled to the system using  $\sigma_{\text{vonMises}} = [(\sigma_1 - \sigma_2)^2 + (\sigma_2 - \sigma_3)^2 + (\sigma_1 - \sigma_3)^2/2]^{1/2}$ governing equation, where  $\sigma_{\rm 1},~\sigma_{\rm 2}$  and  $\sigma_{\rm 3}$  are the principle stresses. The Cauchy stresses, shear stress caused by applied tensile stress, strain and displacement with respect to the initial parameters are also investigated. Firictional forces due to air in the environment and free body forces are ignored. In order to be able to simulate fiber drawing, we used a linear elastic isotropic

model type with large displacement option. Curvature based mesh used with 4 Jacobian points. Temperature distribution in fiber drawing furnace is simulated using COMSOL 4.3 heat transfer model, which follows the first rule of the thermodynamics. We ignored viscous heating and pressure work. Therefore, we concluded that  $\rho C_p \partial T/\partial t + \rho C_p u \cdot \nabla T = \nabla \cdot (k \nabla T) + Q$  is our governing equation, where  $C_p$  is the specific heat capacity, T is the absolute temperature, u is the velocity vector,  $\rho$  is the density, Q is the heating term and t is time. We assumed that mass is always conserved in the furnace which means  $\partial \rho / \partial t + \nabla \cdot (\rho V) = 0$ , where V is the volume. Heat transfer interfaces of the furnace such as out flowing heat boundaries and insulating boundaries use Fourier's law of heat conduction, which means  $q_i = -\sum_i k_{ii} \frac{\partial T}{\partial x_{ii}}$ where  $q_i$  is heat flux,  $k_{ii}$  is anisotropic thermal conductivity tensor and  $x_i$  is distance. This governing equation is also valid for joule heating simulations, which are performed using COMSOL 4.3 software. However, heating term is expressed with  $O = i \cdot E$ equation because joule heating is heat transfer phenomenon related to current density (j) and electric field (E). The linear elastic deflection that occurred due to 60 nN indentation force is also modeled using COMSOL 4.3 software. The simulation is conducted at constant room temperature. Tip radius is chosen as 10 nm for all simulations. Hook's law is used in linear elastic model. Governing equation for total strain, which is a function of displacement gradient, can be expressed as  $\varepsilon = 1/2 \ (\nabla d + \nabla d^T)$ , equation of motion is  $\nabla \cdot \sigma = F_V$ , and strain—stress relation can be expressed as  $\sigma_{ij} = C_{ijkl} \varepsilon_{kl}$ , where  $\varepsilon$  and  $\varepsilon_{kl}$  are the strain tensors,  $\nabla d$ is the gradient of the displacement and  $\nabla d^T$  is the transpose of displacement gradient,  $\sigma$  and  $\sigma_{ij}$  are the Cauchy stress tensors,  $F_V$ is the body force per unit volume and Ciikl is the fourth order stiffness tensor, which is a function of poisson ratio and linear elastic modulus

Device Fabrication and Characterization. We developed two device geometries using micro- and nanoribbons with 100 and 20 mm<sup>2</sup> effective areas, respectively. The first device is built using 50  $\mu$ m thick PVDF microribbons. The microribbons are mechanically extracted out of their polymer jacket and 50 nm gold sputtered on to the both sides as electrical contacts. The second device is fabricated using nanoribbons with 300 nm thickness. Polymer jacket of nanoribbons are etched using DCM, and both sides of PVDF bundles are coated with 50 nm gold using a shadow mask. Finally, the structures are embedded in PDMS (Sygard 184 Silicone Elastomer KIT). In the preperation of PDMS, base and curing agent are mixed using 10:1 ratio. The mixture is degassed for 1 h under 10<sup>-2</sup> Torr vacuum pressure. After pouring the PDMS on PVDF ribbons devices are held under 10<sup>-2</sup> Torr vacuum pressure at room temperature for 2 days. DC resistance of devices are measured by Keithley 2400 Source Meter. Impedance of the devices are measured using Cascade Microtech PM-5 probe station, and analytical data fitting is executed using MATLAB 13.0 software. Current and voltage output of piezoelectric devices are measured with Stanford SR-570 Current Preamplifier and Tetronix TDS-1012B Oscilloscope.

Conflict of Interest: The authors declare no competing financial interest.

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Supporting Information Available: Detailed information about process conditions for transition among  $\alpha$ ,  $\beta$  and  $\gamma$  phases of PVDF, ab initio calculations, preform preparation and consolidation process, fiber drawing process, nanoribbons size distribution, XRD and FTIR analysis, thermal stability of PVDF, experimental setup for piezoelectric characterization of PVDF nanoribbons, device fabrication and characterization. This material is available free of charge via the Internet at http://pubs.acs.org.

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